

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:
Cheung, et al.

Serial No.: 09/609,347

Confirmation No.: 5540

Filed: July 5, 2000

For: Apparatus for Electro-
Chemical Deposition of
Copper Metalization With
Thermal Annealing

Group Art Unit: 1741

Examiner: E. Smith-Hicks

TC 1700

SEP 24 2002

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Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on
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September 18, 2002
Date

B. Todd Patterson
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

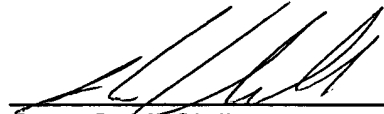
In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.



If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/3421.C1/CMP/ECP/RKK/GGM.

Respectfully submitted,



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